## WHAT IS CLAIMED IS:

- A light scanning system formed on a common substrate comprising:
- a light scanner, integrated on said substrate, for scanning light across a target; and
- a sensor, integrated on said substrate, for detecting light reflected from said target and creating a signal representative of said detected light.
- 2. A light scanning system according to claim 1, wherein said light scanner includes:
- a light source, integrated on said substrate, for producing a light beam; and
- a deflector, integrated on said substrate, for the deflecting said light beam across said target in a desired our said in pattern.
- 3. A light scanning system according to claim 2, wherein said light scanner further includes:
- a first lens for focusing the light beam produced by the light source.
- 4. A light scanning system according to claim 3, wherein said light source is aligned with an optical axis of said first lens.
- 5. A light scanning system according to claim 3, wherein said light source is offset from an optical axis of said first lens.
- 6. A light scanning system according to claim 3, wherein said light scanner further includes:

INNECAN, HENDERSON
FARABOW, CARRETT

8 DUNNER
1 STREET, N.W.
VASHINGTON, DC 20008
1-202-408-4000

a second lens for focusing the light beam deflected by said deflector.

- 7. A light scanning system according to claim 6, wherein said first lens is a positive lens and said second lens is a negative lens.
- 8. A light scanning system according to claim 2, wherein said light scanner further includes:
- a lens for focusing the light beam deflected by said deflector.
- 9. A light scanning system according to claim 2, wherein said deflector comprises a micro-machined scan module.
- 10. A light scanning system according to claim 9, wherein said micro-machined scan module comprises:

a scanning mirror mounted in a center of said sensor;

hinges connected to said detector to allow said detector
and said scanning mirror to rotate about a rotation axis; and

- a frame secured to said substrate for supporting said to hinges.
- 11. A light scanning system according to claim 9, wherein said micro-machined scan module comprises:

an electrode;

- a support mounted on said electrode; and
- a mirror element mounted at one end on said support, and wherein a voltage applied between said electrode and mirror element bends said mirror element.
- 12. A light scanning system according to claim 9, wherein said micro-machined scan module comprises:

INNECAN. HENDERSON
FARABOW, GARRETT

8 DUNNER

0 I STREET, N.W.

MASHINGTON, DC 20005
1-202-408-4000

a scanning mirror;

hinges connected to said scanning mirror to allow said scanning mirror to rotate about a rotation axis; and

- a frame secured to said substrate for supporting said hinges.
- 13. A light scanning system according to claim 12, wherein said rotation axis is perpendicular to a path of said focused light beam from said light source.
- 14. A light scanning system according to claim 12, wherein said light source comprises a laser diode focusing module mounted on a first portion of said substrate.
- 15. A light scanning system according to claim 14, wherein said frame is secured on a second portion of said substrate, which is parallel to said first portion of said substrate.
- 16. A light scanning system according to claim 14, wherein said frame is secured on a second portion of said substrate, which is sloped with respect to said first portion of said substrate cracic
- 17. A light scanning system according to claim 14, wherein said frame is mounted on said first portion of said substrate.
- 18. A light scanning system according to claim 12, wherein said hinges include a shape memory alloy.
- 19. A light scanning system according to claim 18, wherein said shape memory alloy is titanium nickel.
- 20. A light scanning system according to claim 12, wherein said light scanner further includes:

INNECAN. HENDERSON
FARABOW, CARRETT
8 DUNNER
9 I STREET, N.W.
11 AGTON, DC 20005
1-202-408-4000

electrodes for generating an electrostatic force by applying a voltage between each of said electrodes and said scanning mirror.

- 21. A light scanning system according to claim 20, wherein said electrodes include substrate electrodes disposed under said scanning mirror.
- 22. A light scanning system according to claim 21, wherein said electrodes further include upper electrodes disposed above said scanning mirror.
- 23. A light scanning system according to claim 20, wherein said electrodes include upper electrodes disposed above said scanning mirror.
- 24. A light scanning system according to claim Ay wherein accordin

a light source for producing a light beam; and said hinges connected to said light source to allow said light source to rotate about a rotation axis.

AW OFFICES
INEGAN, HENDERSON
FARABOW, GARRETT

8 DUNNER
1 STREET, N. W.

25. A micro-machined mirror for scanning a light beam from an incident path to a desired pattern in a barcode scanner mounted on a common substrate, comprising:

a reflector for reflecting a light beam;

hinges connected to said reflector to allow said reflector to rotate about a rotation axis; and

a frame secured to said substrate for supporting said hinges.

- 26. A micro-machined mirror according to claim 25, wherein said hinges includes a shape memory alloy.
- 27. A micro-machined mirror according to claim 26, wherein said shape memory alloy is nickel titanium.
- 28. A micro-machined mirror according to claim 25, further comprising an electrode for generating an electrostatic force to rotate the reflector around said rotation axis.

NAME OFFICES
NAME OF THE NAME OF THE PROPERTY OF A STREET, N.W.
NOTON, DC 20003
1-202-408-4000

- 29. A method of manufacturing a scanner on a common substrate comprising the steps of:
  - (a) forming a light diode for producing a light beam;
  - (b) mounting said light diode to said common substrate;
- (c) forming a light scanner for scanning the light beam in a desired pattern; and
- (c) mounting said light scanner to said common substrate.
- 30. A method of manufacturing a scanner on a common substrate comprising the steps of:
- (a) forming a light diode for producing a light beam on said common substrate; and
- (b) forming a light scanner for scanning the light beam in a desired pattern on said common substrate.

NNEGAN, HENDERSON FARABOW, GARRETT 8 DUNNER 1 STMEET, M.W. 1-202-408-4000